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Attorney Docket Number	WMI002
Examiner Name	
Art Unit	
First Named Inventor	снои
Filing Date	2/20/2004
Application Number	10/783,772
	Filing Date First Named Inventor Art Unit Examiner Name Attorney Docket Number

	ENCLOSURES (Check all that apply)							
	Fee Transmittal Form Fee Attached Amendment/Repty After Final Affidavits/declaration(s) Extension of Time Request Express Abandonment Request Information Disclosure Statement Certified Copy of Priority Document(s) Response to Missing Parts/ Incomplete Application Response to Missing Parts under 37 CFR 1.52 or 1.53	Rem	Drawing(s) Licensing-related Papers Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence Address Terminal Disclaimer Request for Refund CD, Number of CD(s)		After Allowance communication to Technology Center (TC) Appeal Communication to Board of Appeals and Interferences Appeal Communication to TC (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Other Enclosure(s) (p!ease Identify below): r Art Documents			
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Substitute for form 1449/PTO		Complete if Known			
		Application Number	10/783,772		
INFORM	ATION DISCLOSURE	Filing Date	2/20/2004		
STATEMENT BY APPLICANT (Use as many sheets as necessary)		First Named Inventor	CHOU		
		Art Unit			
		Examiner Name			
et 1	of 2	Attorney Docket Number	WMI002		

Examiner	Cite	Decree and Month of		DOCUMENTS	
Initials*	No.1	Document Number Number-Kind Code ^{2 (# known)}	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	1	^{US-} 6,046,659	04-04-2000	LOO, et al.	
	2	^{US-} 6,331,257	12-18-2001	LOO, et al.	
	3	^{US-} 6,842,097	01-11-2005	HSU, et al.	
	4	^{US-} 6,803,559	10-12-2004	HSU, et al.	
	5	^{US-} 6,667,245	12-23-2003	CHOW, et al.	
	6	^{US-} 5,121,089	06-09-1992	LARSON	
	7	^{US-} 5,578,976	11-26-1996	YAO	
_	8	^{US-} 5,258,591	11-02-1993	BUCK	
	9	^{US-} 5,638,946	06-17-1997	ZAVRACKY	
	10	^{US-} 5,629,565	05-13-1997	SCHLAAK, et al.	
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages		
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Substitute for form 1449/PTO		Complete if Known			
3223				Application Number	10/783,772
INF	ORMATION	DIS	CLOSURE	Filing Date	2/20/2004
STATEMENT BY APPLICANT		First Named Inventor	снои		
	///	-4		Art Unit	
(Use as many sheets as necessary)			ecessary)	Examiner Name	
Sheet	2	of	2	Attorney Docket Number	WMI002

Examiner	Cite	NON PATENT LITERATURE DOCUMENTS Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of	
Initials*	No.1	the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
	1	Petersen, K.E. 1978, "Dynamic micromechanics on silison: techniques and devices."	
	2	Petersen, K.E, "Forming the Contact Surface of Micromechanical Switches", IBM J. Res. Develop., vol.23, No.4, Jul. 1979, pp.376-385	
	3	Daniel Hyman, Juan Lam, Brett Warneke, Adele Schmitz, T. Y. Hsu, Julia Brown, James Schaffner, Andy Walston, Robert Y. Loo, Mehran Mehregany, and Jae Lee, "Surface-micromachined RF MEMS switches on GaAs substrates," International Journal of RF and Microwave CAE, Vol. 9, No. 4, July 1999, pp. 348-361.	
	4	Y. Wang, Z. Li, D. T. McCormick, and N. C. Tien, "A Low-voltage Lateral MEMS Switch with High RF Performance," Journal of MicroElectroMechanical Systems (JMEMS), Vol. 13, No. 6, December 2004, pp. 902-911.	
	5	Yao, J.J., "RF MEMS from a device perspective", Journal Micromechanics and Microengineering 10: R9-R38, 2000	
	6	Zavracky, P.M., Majumdar, S., McGruer,N, 1997, "Micromechanical switches fabricated using nickel surface micromachining', Journal of Microelectromechannical Systems 6(1): 3-9	

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